

Attorney Docket # 10961260-3

<input type="checkbox"/> I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231. Date of Deposit: _____ Typed Name: _____ Signature: _____	<input checked="" type="checkbox"/> I hereby certify that this correspondence is being facsimile transmitted to the Patent and Trademark Office on the date shown below. Date of Facsimile: <u>10/23/2002</u> Typed Name: <u>Katherine Lopez Diazgson</u> Signature: <u>[Signature]</u>
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24/G
 P. Walke
 10-28-02

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor(s): Cao, et al.

Examiner: Douglas Owens

Serial No.: 09/217,740

Group Art Unit: 2811

Filing Date: 12/21/98

Title: Local Oxidation of a Sidewall Sealed Shallow Trench for Providing Isolation Between Devices of a Substrate

Amendment

Dear Sir:

In an Office Action dated 28 August 2002, having a three-month statutory period expiring 28 November 2002, Applicants respectfully request reconsideration of the application in view of the following Amendments and Remarks. Please amend the specification as follows:

In the claims:

1. (Amended) A semiconductor isolation structure comprising:

- a substrate, the substrate comprising a surface;
- a first device and a second device formed within the substrate;
- an isolation region formed within the substrate between the first device and the second device, the isolation region comprising:
 - a deep region which extends into the substrate, the deep region comprising
 - a deep region cross-sectional area;

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OCT 23 2002

TECHNOLOGY CENTER 2800

AGILENT TECHNOLOGIES, INC.
Legal Department, DL429
Intellectual Property Administration
P. O. Box 7599
Loveland, Colorado 80537-0599

PATENT APPLICATION

ATTORNEY DOCKET NO. 10961260-3

IN THE
UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor(s): Min Cao et al

Serial No.: 09/217740

Examiner: Owens, Douglas W.

Filing Date: Dec 21, 1998

Group Art Unit: 2811

Title: Local Oxidation Of A Sidewall Sealed Shallow Trench For Providing Isolation Between
Devices Of A Substrate

COMMISSIONER FOR PATENTS
Washington, D.C. 20231

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TRANSMITTAL LETTER FOR RESPONSE/AMENDMENT

Sir:

TECHNOLOGY CENTER 2800

Transmitted herewith is/are the following in the above-identified application:

- (X) Response/Amendment () Petition to extend time to respond
() New fee as calculated below () Supplemental Declaration
(X) No additional fee (Address envelope to "Box Non-Fee Amendments")
() Other: (fee \$)

CLAIMS AS AMENDED BY OTHER THAN A SMALL ENTITY						
(1) FOR	(2) CLAIMS REMAINING AFTER AMENDMENT	(3) NUMBER EXTRA	(4) HIGHEST NUMBER PREVIOUSLY PAID FOR	(5) PRESENT EXTRA	(6) RATE	(7) ADDITIONAL FEES
TOTAL CLAIMS	5	MINUS	20	= 0	X \$18	\$ 0
INDEP. CLAIMS	2	MINUS	3	= 0	X \$84	\$ 0
[] FIRST PRESENTATION OF A MULTIPLE DEPENDENT CLAIM					+ \$280	\$ 0
EXTENSION FEE	1ST MONTH \$110.00	2ND MONTH \$400.00	3RD MONTH \$920.00	4TH MONTH \$1440.00		\$ 0
OTHER FEES						\$
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT						\$ 0

Charge \$ 0 to Deposit Account 50-1078. At any time during the pendency of this application, please charge any fees required or credit any overpayment to Deposit Account 50-1078 pursuant to 37 CFR 1.25. Additionally please charge any fees to Deposit Account 50-1078 under 37 CFR 1.16, 1.17, 1.19, 1.20 and 1.21. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

I hereby certify that this paper is being facsimile
transmitted to the Patent and Trademark Office on
the date shown below.

Date of Facsimile: 10/23/2002

Typed Name: Katherine Lopez-Diagonson

Signature: 

Min Cao et al

By 

Judy Liao Shie

Attorney/Agent for Applicant(s)

Reg. No. 50,305

Date: 10/23/2002

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